

REPLY UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
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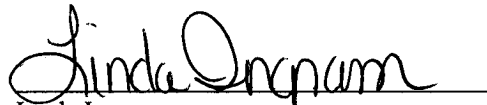
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	§	Attorney Docket No.
Hsien-Wei Chen, et al.	§	2003-1410 / 24061.193
	§	
Serial No.: 10/801,475	§	Customer No. 42717
	§	
Filed: March 16, 2004	§	Group Art Unit: 2822
	§	
For: SYSTEM FOR HEAT	§	Examiner: Monica Lewis
DISSIPATION IN	§	
SEMICONDUCTOR DEVICES	§	Confirmation No.: 1783

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Sir:

I hereby certify that this correspondence (including any listed enclosures) is being electronically filed in the United States Patent and Trademark Office via the EFS-Web system on October 9, 2007.


Linda Ingram

RESPONSE UNDER 37 C.F.R. §1.116

This Response is submitted in reply to the Office Action mailed on September 14, 2007.
(Please see the pages that follow).